

Notice of References CitedApplication/Control No.
09/276,803Applicant(s)/Patent Under
Reexamination
LEE ET AL.Examiner
Neal BereznyArt Unit
2823

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
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	B	US- -				
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	I	US- -				
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	K	US- -				
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	M	US- -				

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*	N	WO-96/02067-	01-1996	PCT	Azuma et al.	H01L	21/3205
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.